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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:

Hidefumi NAKATA

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Group Art Unit: ----

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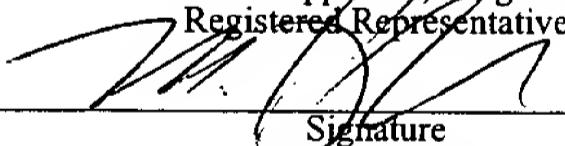
Examiner: -----

For: **MIM CAPACITOR AND MANUFACTURING METHOD THEREFOR**COPY OF PAPERS  
ORIGINALLY FILED #5Cte.  
with  
Formal  
DRAWINGS  
10-7-02  
redateAssistant Commissioner for Patents  
Washington, DC 20231**Attention: Official Draftsperson****FORMAL DRAWINGS**

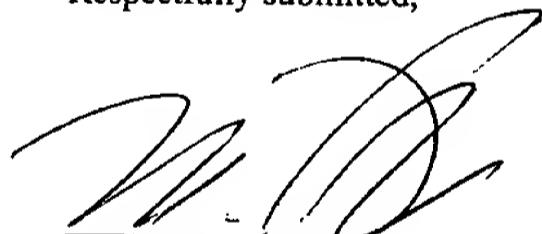
Sir:

Enclosed herewith please find three (3) sheets of formal drawings containing Figures 1-4D for the above-identified application.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on March 4, 2002:

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Signature  
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Date of Signature

Respectfully submitted,



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